



AF-1765

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RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1765

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED
MAY 30 2003
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In re the Application of:

KIRIMURA et al.

Art Unit: 1765

Application No.: 09/822,414

Examiner: M. Song

Filed: April 2, 2001

Attorney Dkt. No.: 107351-00011

For: FILM FORMING APPARATUS AND METHOD OF FORMING A CRYSTALLINE
SILICON FILM

AMENDMENT AFTER RECONSIDERATION AFTER FINAL REJECTION

BOX AF

Commissioner for Patents
P.O. Box 1450
Arlington, VA 22313-1450

May 27, 2003

Sir:

In reply to the outstanding Office Action dated February 26, 2003, (with May 26, 2003 being a holiday), please amend the above-identified patent application as follows: